

<b>Notice of References Cited</b>	Application/Control No. 10/537,975		Applicant(s)/Patent Under Reexamination JONGEN ET AL.	
	Examiner Rick Palabrica		Art Unit 3663	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-3,349,001	10-1967	MYLES STANTON RICHARD	376/193
*	C	US-7,200,198	04-2007	Wieland et al.	376/195
*	D	US-6,917,044	07-2005	Amini, Behrouz	250/492.1
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	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Shaeffer et al., "Design of a 18F Production System at ORNL 86-Inch Cyclotron," ORNL/MIT-25810/19/77, pp. 1-16.
	V	Wieland, "Foil Sealing Assembly used on 11 MeV Proton Targets," Proceedings of the First Workshop on Targetry and Target Chemistry, Heidelberg, West Geramny, October 4-7, 1985, pp. 14-16.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.